

12 Hm Copy of #9/A

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Atty. Dkt. No. AMATM47/CPI/COPPER/PJS

PATENT

In re Application of:
Zheng et al.

Serial No.: 09/614,407

Confirmation No.: 1903

Filed: July 12, 2000

For: Method of Application of
Electrical Biasing to
Enhance Metal Deposition

Group Art Unit: 1741

Examiner: Smith-Hicks, E.

OFFICIAL
FAX RECEIVED
JUL 15 2002
GROUP 1700

Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

CERTIFICATE OF FAX 37 CFR 1.8	
I hereby certify that this correspondence is being facsimile transmitted to the Patent and Trademark Office to the fax number indicated by the Examiner, namely (703) 872-0310 to the attention of the named Examiner, on the date below.	
Date 5/30/02	Signature Art O. Prasad

RESPONSE TO OFFICE ACTION DATED APRIL 10, 2002

In response to the Office Action dated April 10, 2002, having a shortened statutory period for response set to expire on July 10, 2002, please enter the following amendments and reconsider the claims pending in the application for reasons discussed below. The Commissioner is authorized to charge Deposit Account No. 20-0782/4471/CPI/COPPER/PJS in the amount of \$396.00 for the addition of 22 new dependent claims and any other fees necessary to make this response timely.

IN THE SPECIFICATION:

Please amend the specification at page 15, line 31, as follows:

Step 2: This step involves attracting the metal ions in close proximity to the entire topography of the seed layer on the substrate including the portion of the seed

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